## **CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to the Commissioner for Patents and Trademarks, Washington, D.C. 20231, on May 17, 2002.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

JUN 0 3 2002 E

Grace Alicea

y Re Application of:

Date: May 17, 2002

OKUDA, et al.

Serial No.: 10/018,708

Group Art Unit: to be gssigned

Filed: Dec. 13, 2001

Examiner: to be assigned.

For:

TABLE OF WAFER POLISHING APPARATUS, METHOD FOR POLISH

SEMICONDUCTOR WAFER, AND METHOD FOR MANUFACTURING

SEMICONDUCTOR WAFER

Assistant Commissioner of Patents Washington, D.C. 20231

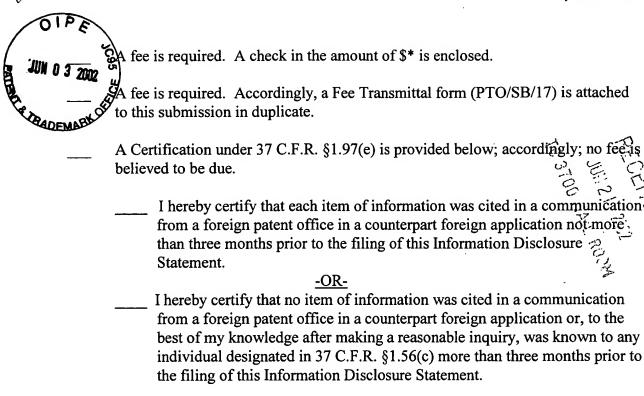
With assiss

## INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Sir:

Pursuant to 37 C.F.R. §1.97 and §1.98, Applicants submit for consideration in the above-identified application the documents listed on the attached Form PTO-1449. The Examiner is requested to make these documents of record. This Information Disclosure Statement is being submitted:

	with copies.
<del></del>	Without copies. Copies of the documents were previously submitted in an Information Disclosure Statement and/or Office Action, directed to the related application Serial No.* filed *. This protocol conforms with 37 C.F.R. §1.98(d) and M.P.E.P. 609 (A)(2).
	With the application; accordingly, no fee or separate requirements are required.
X	Within three months of the application filing date or <u>before mailing of a first Office</u> Action on the merits; accordingly, no fee or separate requirements are required.
	The documents listed on the attached Form PTO-1449 were cited in a Search Report directed to a counterpart international or foreign application.
	After receipt of a first Office Action on the merits before mailing of a final Office Action or Notice of Allowance



After mailing of a final Office Action or Notice of Allowance, but before payment of the issue fee. Accordingly, a Petition requesting consideration of the Information Disclosure Statement, and a Certification under 37 C.F.R. §1.97(e) is provided herein.

Applicants would appreciate the Examiner initialing and returning the Form PTO-1449, indicating that the information has been considered and made of record herein.

The Commissioner is hereby authorized to charge any additional fees or credit any overpayment to Deposit Account 02-2120 (Sawyer Law Group LLP). If any unresolved issues remain, please contact Applicant's attorney at the telephone number indicated below.

Respectfully submitted,

Sawyer Law Group LLF Attorney for Applicant

Reg. No. 30,801 (650) 493-4540

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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.